-1-

H30 3/12/02/8/14

Docket No. 0756-1921

RECEIVED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 5 2003

*		
In re Patent Application of)	TC 2800 HAIL ROOM
Hisashi OHTANI et al)	
Serial No. 09/226,216)	Group Art Unit: 2814
Filed: January 7, 1999)	Examiner: Cao, Phat X.
For: SEMICONDUCTOR DEVICE AND)	CERTIFICATE OF MAILING
METHOD OF MANUFACTURING)	I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20131, on Polymer Commissioner
THE SAME).	

REQUEST FOR ACKNOWLEDGMENT OF INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

Applicants acknowledge with appreciation the Official Action mailed January 2, 2002.

The Official Action did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statement filed March 2, 1999. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the Information Disclosure Statement of March 2, 1999 by providing a copy of the initialed Form PTO-1449.

If a conference would beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,

Eric J. Robinson Registration No. 38,285

NIXON PEABODY LLP 8180 Greensboro Drive, Suite 800 McLean, Virginia 22102 (703) 790-9110 (703) 883-0370 (FAX)